

REVIEW

Cite this: *Nanoscale*, 2016, 8, 6435

Review on the Raman spectroscopy of different types of layered materials†

Xin Zhang,* Qing-Hai Tan, Jiang-Bin Wu, Wei Shi and Ping-Heng Tan*

Two-dimensional layered materials, such as graphene and transition metal dichalcogenides (TMDs), have been under intensive investigation. The rapid progress of research on graphene and TMDs is now stimulating the exploration of different types of layered materials (LMs). Raman spectroscopy has shown its great potential in the characterization of layer numbers, interlayer coupling and layer-stacking configurations and will benefit the future explorations of other LMs. Lattice vibrations or Raman spectra of many LMs in bulk have been discussed since the 1960s. However, different results were obtained because of differences or limitations in the Raman instruments at early stages. The developments of modern Raman spectroscopy now allow us to revisit the Raman spectra of these LMs under the same experimental conditions. Moreover, to the best of our knowledge, there were limitations in detailed reviews on the Raman spectra of these different LMs. Here, we provide a review on Raman spectra of various LMs, including semiconductors, topological insulators, insulators, semi-metals and superconductors. We firstly introduce a unified method based on symmetry analysis and polarization measurements to assign the observed Raman modes and characterize the crystal structure of different types of LMs. Then, we revisit and update the positions and assignments of vibration modes by re-measuring the Raman spectra of different types of LMs and by comparing our results to those reported in previous papers. We apply the recent advances on the interlayer vibrations of graphene and TMDs to these various LMs and obtain their shear modulus. The observation of the shear modes of LMs in bulk facilitates an accurate and fast characterization of layer numbers during preparation processes in the future by a robust layer-number dependency on the frequencies of the shear modes. We also summarize the recent advances on the layer-stacking dependence on the intensities of interlayer shear vibrations. Finally, we review the recent advances on Raman spectroscopy in the characterization of anisotropic LMs, such as black phosphorus and rhenium diselenide. We believe that this review will benefit the future research studies on the fundamental physics and potential applications of these various LMs, particularly when they are reduced down to monolayers or multilayers.

Received 16th October 2015,
Accepted 14th February 2016

DOI: 10.1039/c5nr07205k

www.rsc.org/nanoscale

1 Introduction

The rapid progress of graphene research, fueled by the unique properties of this two-dimensional (2D) material, has paved the way to experiments on other layered materials (LMs).^{1–3} Transition metal dichalcogenides (TMDs), represented by MX₂ (M = Mo, W; X = S, Se, Te), have received extensive attention due to their distinctive electronic and optical properties, and broad applications in devices.^{4–9} Bulk MX₂ is an indirect-gap semiconductor, but undergoes a transition to a direct-gap semiconductor in monolayer (1L)-MX₂ because of the absence

of interlayer coupling.^{4,5} Valley polarization and the enhanced excitonic effect have been revealed in 1L-MX₂.⁸ MX₂ also shows fine-tuned properties because of external perturbations, such as strain, pressure, temperature and electromagnetic field.¹⁰ The advances on TMDs further accelerate the experiments on different types of LMs. Actually, LMs constitute a large family including the graphene family, 2D dichalcogenides and 2D oxides, which ranges from insulators (BN, HfS₂ *etc.*), topological insulators (Bi₂Se₃, Bi₂Te₃ *etc.*), semiconductors (MX₂, GaSe, GaS, CuS, SnSe₂, PbSnS₂, GeSe, SnS, ReSe₂ *etc.*), semi-metals (graphene) to superconductors (NbSe₂, NbS₂, FeSe, FeTe *etc.*).^{1,10} These LMs differ in atomic composition, crystal structure and electronic structure, which necessitates an effective method to classify them. One way is based on the electronic structure as mentioned above. We can also classify these LMs according to the symmetry of their crystal structures. For example, graphite, TMDs, GaSe(S), CuS, SnS(Se)₂, TaS(Se)₂,

State Key Laboratory of Superlattices and Microstructures, Institute of Semiconductors, Chinese Academy of Sciences, Beijing 100083, China.

E-mail: zhangxin@semi.ac.cn, phtan@semi.ac.cn

†Electronic supplementary information (ESI) available. See DOI: 10.1039/C5NR07205K

FeTe(Se), NbSe₂ and BN belong to D_{6h} , SnSe₂ and Bi₂Te(Se)₃ belong to D_{3d} , black phosphorus (BP), GeS(Se) and SnS(Se) belong to D_{2h} , GaTe belongs to C_{2h} and ReS(Se)₂ belongs to C_i . Fig. 1 shows five representative LMs from D_{6h} , D_{3d} , D_{2h} , C_{2h} and C_i symmetries. While much advance has been made on LMs that have D_{6h} symmetry, such as graphite and TMDs, those LMs with low symmetry (*e.g.*, D_{3d} and D_{2h}) are just beginning to receive attention. Recently, BP became very popular because it has very high mobility and shows in-plane optical anisotropy. Actually, such an in-plane optical anisotropy comes from the symmetric nature of D_{2h} in BP. Thus, a similar in-plane optical anisotropy is expected in GeS(Se) and SnS(Se). It should be noted here that the symmetry is limited within bulk LMs. Because of the absence of out-of-plane transitional symmetry in multilayer structures, the symmetry in bulk LMs will reduce in few layer structures. For example, D_{6h} in bulk TMDs reduces to D_{3h} (odd layer numbers) and D_{3d} (even layer numbers) for few-layer TMDs.¹⁰ The atoms within each layer in LMs are joined together by covalent bonds, while van der Waals interactions keep the layers together, which makes the physical and chemical properties of LMs strongly dependent on their thickness (or layer numbers).¹⁰ The adjacent layers in most LMs are weakly coupled to each other and can be easily exfoliated and isolated down to 1L and few layers, whose properties are waiting for explorations. In addition, these various

LMs could be re-stacked/assembled horizontally or vertically in a chosen sequence to form van der Waals heterostructures (vdWHs), which can offer huge opportunities for designing the functionalities of such heterostructures.^{1,2,11–15} Two or more LMs with similar properties can be alloyed into a new type of LM, namely, 2D alloy, which can offer tunable band gaps for promising applications in nanoelectronics and optoelectronics.^{16–19}

Raman spectroscopy is becoming increasingly important in the area of LMs.¹⁰ Raman spectroscopy can reveal information on the crystal structure, electronic structure, lattice vibrations and flake thickness of LMs, and can be used to probe the strain, stability, charger transfer, stoichiometry, and stacking orders of LMs.¹⁰ In particular, the unique interlayer vibrations have been widely used to develop a substrate-free layer-number identification of LMs,^{19,20} and to probe the strength of interlayer coupling in LMs^{20,21} and the interface coupling in artificial vdWHs.^{13,15} Raman studies of many LMs started from the 1960s, but early Raman measurements were mainly limited to bulk LMs.^{22–24} Following the successful exfoliation of monolayer graphene in 2004 and monolayer MoS₂ in 2010,^{25,26} we should take a fresh look at these bulk LMs. Raman spectra of graphene and TMDs from monolayer, multilayer to bulk are well-known,^{10,27} but those of other LMs are still waiting for investigations and revisits. On the other hand, Raman spectra

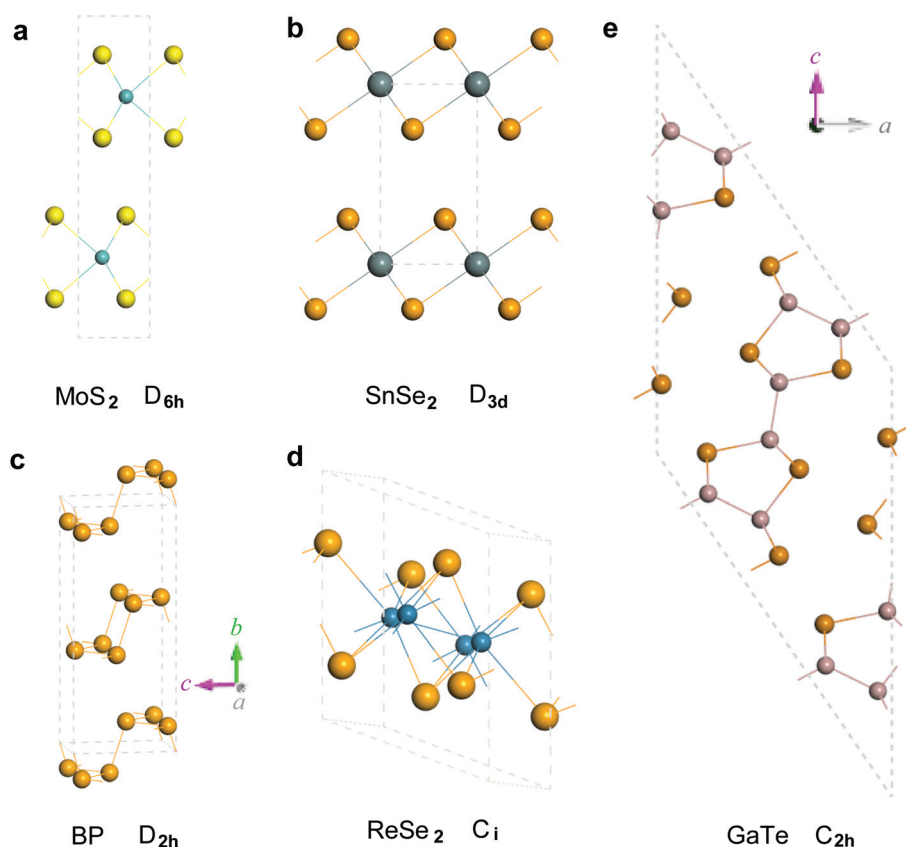


Fig. 1 Atomic structures of five representative LMs (including their symmetries): (a) MoS₂ (D_{6h}), (b) GaSe (D_{3d}), (c) black phosphorus (BP) (D_{2h}), (d) ReSe₂ (C_i) and (e) GaTe (C_{2h}).

at the early stage strongly depend on the Raman spectroscopy instrument, which usually leads to different peak positions and different profiles with large uncertainties resulting from the sample purity and the instrument setup. The significant developments of modern Raman spectroscopy now allow us to revisit Raman spectra of these LMs. Moreover, the ultralow-frequency technique developed by Tan *et al.* in 2012 makes it possible to detect interlayer vibrations with frequencies down to several wavenumbers, which helps us to access the interlayer vibrations of multilayer graphene and TMDs.^{13,15,19–21} To meet the growing demand for Raman characterization of LMs, we review the Raman spectra of different types of LMs from the 1960s. Because of the limitations of early Raman spectroscopy and sample purity, we re-measured the Raman spectra of LMs from several wavenumbers. By comparing our results to those reported in previous papers, we revisit and update the peak positions and the corresponding assignments. We firstly take three representative LMs that have different symmetries as examples to introduce a unified method to assign the vibration modes by symmetry analysis and polarization measurements. Then we discuss the Raman spectra of different types of LMs using three subsections: Semiconductors, Topological insulators, and Superconductors, semi-metals, and insulators. Furthermore, we apply the recent advances on the interlayer vibrations of multilayer graphene and TMDs to many LMs from which we obtain their shear modulus. We also summarize recent advances on the layer-stacking dependence on the intensities of interlayer vibrations. Finally, we review the recent advances on Raman study of in-plane anisotropy in anisotropic LMs, such as black phosphorus and rhenium diselenide. We hope that this review will enable a fresh understanding of the Raman results obtained in the past fifty years and be helpful to the studies of these LMs when they are reduced down to monolayers and few layers.

2 Method to assign Raman peaks in LMs

Lattice vibrations are usually denoted by the irreducible representations of the factor group of crystals.²⁸ From its denotations, we can determine the optical activities of this vibration, *i.e.*, Raman (R) active, Infrared (IR) active or optically silent. The intensity of a Raman-active mode is expressed by the defined Raman tensor (Rt) as:²⁸ $d\sigma/d\Omega \propto \sum_j |e_s \cdot \text{Rt}_j \cdot e_i|^2$,

where Rt_j is the j th Raman tensor of the vibration mode. e_i and e_s are the polarization vectors of the incoming and scattered photons, respectively. e_i (e_s) along x , y , z is $(1, 0, 0)$, $(0, 1, 0)$, $(0, 0, 1)$, respectively. One can use four letters, A(BC)D, to represent the different scattering configurations in Raman measurements. “A” and “D” are the propagation directions of incoming and scattered photons, while “B” and “C” are the polarized directions of incoming (e_i) and scattered (e_s) photons. Under the back scattering conditions, “A” and “D” are fixed along Z and \bar{Z} (the opposite direction of Z), respectively.

Thus, $Z(\text{BC})\bar{Z}$ can simply be denoted by BC. There are four scattering configurations under back scattering conditions, XX, XY, YX and YY. XX and YY are called unpolarized configurations, while XY and YX are polarized configurations. Raman tensors can be obtained from the standard textbooks and review articles.^{28,29} Next, we will take MoS_2 (D_{6h}),^{20,30} Bi_2Se_3 (D_{3d})^{31–33} and GeSe (D_{2h})^{34,35} as examples to introduce the method to assign Raman peaks in the Raman spectra.

The factor group at the Γ point is the point group the crystal belongs to;²⁸ thus, it is D_{6h} for bulk MoS_2 , D_{3d} for bulk Bi_2Se_3 and D_{2h} for bulk GeSe . Because there are two Mo atoms and four S atoms in the unit cell of bulk MoS_2 , 18 normal vibration modes at the Γ point are expected and denoted by:^{36,37} $\Gamma = A_{1g} + 2A_{2u} + 2B_{2g} + B_{1u} + E_{1g} + 2E_{1u} + 2E_{2g} + E_{2u}$, where 3 acoustic modes are $A_{2u} + E_{1u}$, 15 optical modes are $A_{1g} + A_{2u} + 2B_{2g} + B_{1u} + E_{1g} + E_{1u} + 2E_{2g} + E_{2u}$. Raman and infrared active modes can be determined from the character table for D_{6h} (please see Table S1 in the ESI†). Those irreducible representations (marked in red in Table S1 in the ESI†) transformed as a quadratic term of x , y , z (*e.g.*, $x^2 \pm y^2$, z^2 , xz , yz and xy) are Raman active, while those (marked in blue in Table S1 in the ESI†) as a linear term (*i.e.*, x , y , z) are infrared active. The remaining irreducible representations are optically silent and principally cannot be detected by Raman or infrared spectroscopy.^{28,37} Thus, for bulk MoS_2 , A_{2u} and E_{1u} among 15 optical modes are infrared active, while A_{1g} , E_{1g} and $2E_{2g}$ are Raman active, and $2B_{2g}$, B_{1u} and E_{2u} are optically silent. We observed three modes, $\sim 32.5 \text{ cm}^{-1}$, $\sim 383.3 \text{ cm}^{-1}$ and $\sim 408.6 \text{ cm}^{-1}$ under the XX configuration, as shown in Fig. 2. However, the mode $\sim 408.6 \text{ cm}^{-1}$ almost disappears under the YX configuration, while the other two modes keep their intensity almost unchanged. The polarization-dependent intensity of a Raman mode is determined by its Raman tensor (Rt). The Raman tensors (Rt) of A_{1g} , E_{1g} and E_{2g} are presented, respectively, as follows:²⁹

$$A_{1g}(D_{6h}) : \begin{pmatrix} a & 0 & 0 \\ 0 & a & 0 \\ 0 & 0 & b \end{pmatrix}$$

$$E_{1g}(D_{6h}) : \begin{pmatrix} 0 & 0 & 0 \\ 0 & 0 & c \\ 0 & c & 0 \end{pmatrix}, \begin{pmatrix} 0 & 0 & -c \\ 0 & 0 & 0 \\ -c & 0 & 0 \end{pmatrix}$$

$$E_{2g}(D_{6h}) : \begin{pmatrix} 0 & d & 0 \\ d & 0 & 0 \\ 0 & 0 & 0 \end{pmatrix}, \begin{pmatrix} d & 0 & 0 \\ 0 & -d & 0 \\ 0 & 0 & 0 \end{pmatrix}$$

Both E_{1g} and E_{2g} have two Raman tensors (Rt_1 and Rt_2) because they are doubly degenerate within the xy plane. The intensity of the A_{1g} mode, $I(A_{1g})$, under the XX ($e_s = (1, 0, 0)$, $e_i = (1, 0, 0)$) configuration is $I(A_{1g}) \propto |e_s \cdot \text{Rt} \cdot e_i|^2 = a^2$, while under the YX ($e_s = (0, 1, 0)$, $e_i = (1, 0, 0)$) configuration $I(A_{1g}) = 0$. This suggests that the A_{1g} mode will disappear when the polarization configuration is changed from XX to YX. Thus, the mode $\sim 408.6 \text{ cm}^{-1}$ is assigned as A_{1g} . In a similar way, we have the expression of $I(E_{2g}) \propto |e_s \cdot \text{Rt}_1 \cdot e_i|^2 + |e_s \cdot \text{Rt}_2 \cdot e_i|^2 = d^2$ for both XX

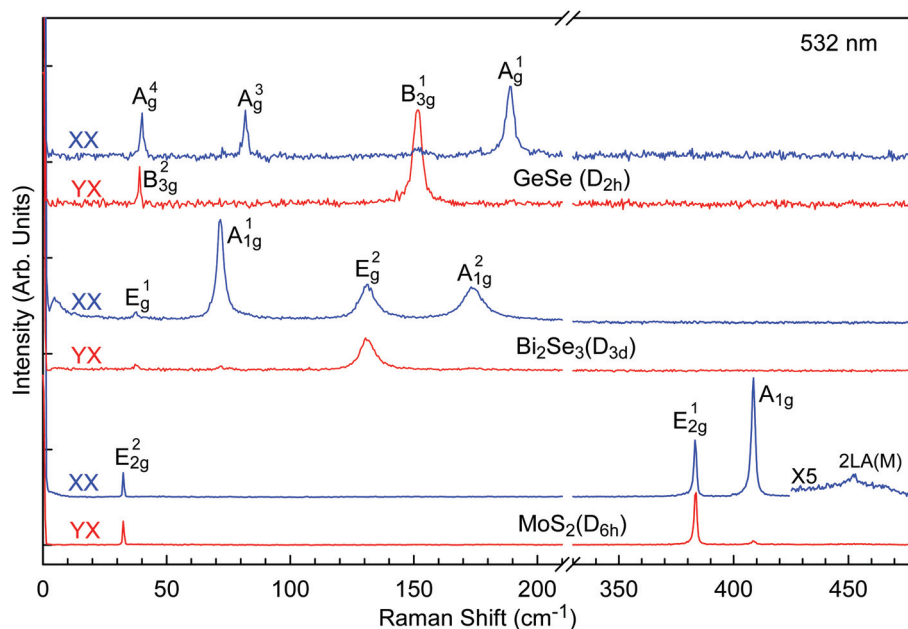


Fig. 2 Raman spectra of three representative bulk materials, GeSe (D_{2h}), Bi_2Se_3 (D_{3d}) and MoS_2 (D_{6h}), under XX and YX polarization configurations.

and YX configurations, which suggests that the E_{2g} mode will keep its intensity unchanged. Here R_{t1} and R_{t2} are two Raman tensors of the E_{2g} mode. Thus, we assign the two modes at $\sim 32.5 \text{ cm}^{-1}$ and $\sim 383.3 \text{ cm}^{-1}$ as E_{2g} . We further use superscript numbers “1” and “2” for E_{2g} to distinguish the modes with the same symmetry, *i.e.*, E_{2g}^1 ($\sim 383.3 \text{ cm}^{-1}$) and E_{2g}^2 ($\sim 32.5 \text{ cm}^{-1}$). This can be generally applicable to the other modes. It should be noted that the E_{1g} mode cannot be observed for both XX and YX configurations because $I(E_{1g}) = 0$. The broad peak at $\sim 452.0 \text{ cm}^{-1}$ comes from 2LA(M) (Fig. 2).³⁸

For bulk Bi_2Se_3 , there are 15 normal vibration modes, which are expressed as follows: $\Gamma = 2A_{1g} + 3A_{2u} + 2E_g + 3E_u$, where $2A_{1g}$ and $2E_g$ are Raman active, and $3A_{2u}$ and $3E_u$ are infrared active. The Raman tensors (Rt) of the A_{1g} and E_g modes are presented as follows:²⁹

$$A_{1g}(D_{3d}) : \begin{pmatrix} a & 0 & 0 \\ 0 & a & 0 \\ 0 & 0 & b \end{pmatrix}$$

$$E_g(D_{3d}) : \begin{pmatrix} c & 0 & 0 \\ 0 & -c & d \\ 0 & d & 0 \end{pmatrix}, \begin{pmatrix} 0 & -c & -d \\ -c & 0 & 0 \\ -d & 0 & 0 \end{pmatrix}$$

Based on the above Raman tensors, the E_g mode can be observed under both XX and YX configurations, while the A_{1g} mode is observable only under the XX configuration. Thus, we assign the four observed modes in Fig. 2 as E_g^1 ($\sim 37.1 \text{ cm}^{-1}$), A_{1g}^1 ($\sim 71.6 \text{ cm}^{-1}$), E_g^2 ($\sim 130.8 \text{ cm}^{-1}$) and A_{1g}^2 ($\sim 173.6 \text{ cm}^{-1}$).³³

For bulk GeSe, there are two layers in its unit cell; each of them contains four atoms.^{39,40} Thus, 24 normal vibration modes are expected and denoted as follows: $\Gamma = 4A_g + 4B_{1u} + 2B_{1g} + 2A_u + 4B_{2g} + 4B_{3u} + 2B_{3g} + 2B_{2u}$, where $4A_g$, $2B_{1g}$, $4B_{2g}$

and $2B_{3g}$ are Raman active.³⁴ Their Raman tensors (Rt) are as follows:²⁹

$$A_g(D_{2h}) : \begin{pmatrix} a & 0 & 0 \\ 0 & b & 0 \\ 0 & 0 & c \end{pmatrix}$$

$$B_{1g}(D_{2h}) : \begin{pmatrix} 0 & d & 0 \\ d & 0 & 0 \\ 0 & 0 & 0 \end{pmatrix}$$

$$B_{2g}(D_{2h}) : \begin{pmatrix} 0 & 0 & e \\ 0 & 0 & 0 \\ e & 0 & 0 \end{pmatrix}$$

$$B_{3g}(D_{2h}) : \begin{pmatrix} 0 & 0 & 0 \\ 0 & 0 & f \\ 0 & f & 0 \end{pmatrix}$$

We should note here that the scattering configuration, $A(BC)D$, is defined in the experimental coordinates (x, y, z), but the above Raman tensors (Rt) are actually defined in the crystal coordinates (a, b, c). For MoS_2 and Bi_2Se_3 , the direction of the layer stacking is along c , which is set along the z axis. Thus, the crystal and experimental coordinates are the same. However, the direction of the layer stacking in GeSe ($a = 10.825 \text{ \AA}$, $b = 3.833 \text{ \AA}$, $c = 4.388 \text{ \AA}$) is along a which is taken along the z axis.⁴¹ Thus, the Raman tensor (Rt) needs to be converted from the crystal coordinates to the experimental coordinates, and the new Raman tensor (Rt') in the experimental coordinates can be obtained using:

$$Rt' = TRtT^{-1}, \quad (1)$$

where T is the transform matrix from the crystal coordinates (a , b , c) to the experimental coordinates (x , y , z). T^{-1} is the inverse matrix of T . Here, we need to clockwise rotate $\pi/2$ about the b axis. Thus, T is

$$T : \begin{pmatrix} 0 & 0 & -1 \\ 0 & 1 & 0 \\ 1 & 0 & 0 \end{pmatrix}$$

and thus we obtain Rt' using eqn (1) as follows:

$$A_g(D_{2h}) : \begin{pmatrix} c & 0 & 0 \\ 0 & b & 0 \\ 0 & 0 & a \end{pmatrix}$$

$$B_{1g}(D_{2h}) : \begin{pmatrix} 0 & 0 & 0 \\ 0 & 0 & d \\ 0 & d & 0 \end{pmatrix}$$

$$B_{2g}(D_{2h}) : \begin{pmatrix} 0 & 0 & -e \\ 0 & 0 & 0 \\ -e & 0 & 0 \end{pmatrix}$$

$$B_{3g}(D_{2h}) : \begin{pmatrix} 0 & -f & 0 \\ -f & 0 & 0 \\ 0 & 0 & 0 \end{pmatrix}$$

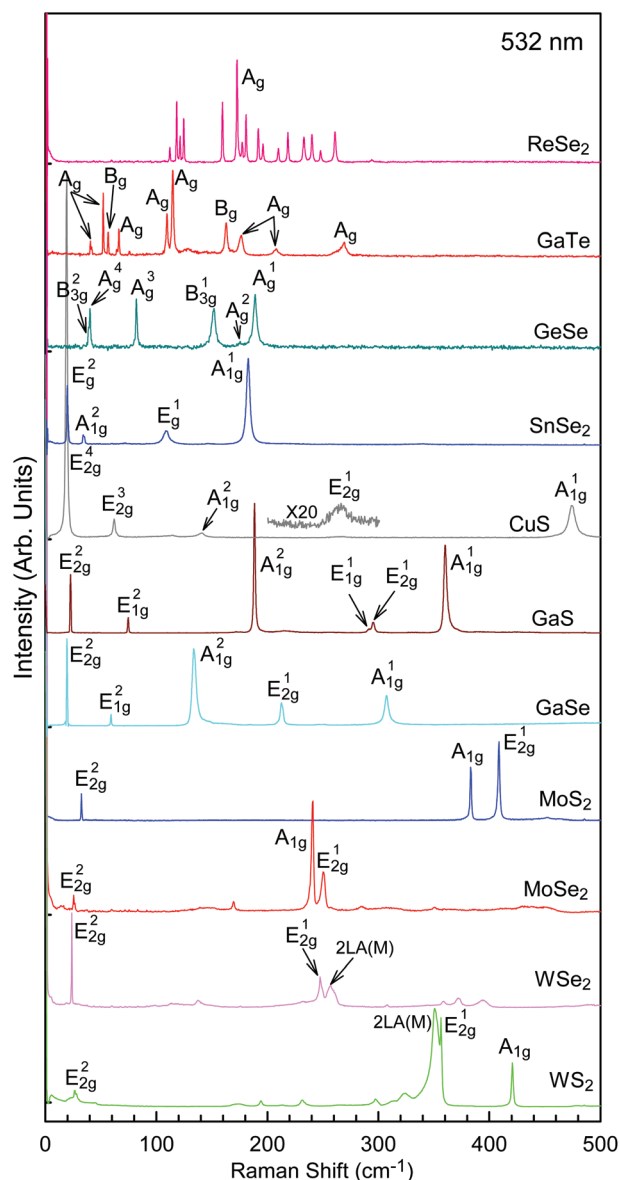
We observed three modes under the XX configuration, $\sim 40 \text{ cm}^{-1}$, $\sim 82 \text{ cm}^{-1}$ and $\sim 188 \text{ cm}^{-1}$, and another two modes under the YX configuration, $\sim 39 \text{ cm}^{-1}$ and $\sim 151 \text{ cm}^{-1}$, as shown in Fig. 1. Based on their Raman tensors (Rt'), we have $I(A_g) = c^2$, $I(B_{1g}) = 0$, $I(B_{2g}) = 0$ and $I(B_{3g}) = 0$ under the XX configuration, and $I(A_g) = 0$, $I(B_{1g}) = 0$, $I(B_{2g}) = 0$ and $I(B_{3g}) = f^2$ under the YX configuration. Thus, we assign the five modes as A_g^4 ($\sim 40 \text{ cm}^{-1}$), A_g^3 ($\sim 82 \text{ cm}^{-1}$) and A_g^1 ($\sim 188 \text{ cm}^{-1}$), B_{3g}^2 ($\sim 39 \text{ cm}^{-1}$) and B_{3g}^1 ($\sim 151 \text{ cm}^{-1}$).³⁴ The four A_g modes can be observed under the XX configuration from the symmetry classification. However, we just observed three of them by the 532 nm excitation. Actually, another mode $\sim 175 \text{ cm}^{-1}$ is detected by the 633 nm excitation and assigned as A_g^2 , as shown in Fig. S1 in the ESI.† We can also convert the experimental coordinates (x , y , z) to the crystal coordinates (a , b , c). Under the clockwise rotation of $\pi/2$ about the b axis, we have $a = z$, $b = y$, $c = -x$. Thus, the scattering configurations, $Z(XX)\bar{Z}$ and $Z(YX)\bar{Z}$, are changing into $a(cc)\bar{a}$ and $a(bc)\bar{a}$, respectively. Thus, based on the Raman tensors (Rt), the A_g mode appears under $a(cc)\bar{a}$ ($Z(XX)\bar{Z}$) while the B_{3g} mode under $a(bc)\bar{a}$ ($Z(YX)\bar{Z}$). The above two methods are equivalent. It should be noted here that BP ($a = 3.314 \text{ \AA}$, $b = 10.478 \text{ \AA}$, $c = 4.376 \text{ \AA}$) also belongs to D_{2h} .⁴² However, the direction of layer stacking is along the b axis. Under the counterclockwise rotation of $\pi/2$ about the a axis, we have $a = x$, $b = z$, $c = -y$. Thus, the scattering configurations $Z(XX)\bar{Z}$ and $Z(YX)\bar{Z}$ are changed into $b(aa)\bar{b}$ and $b(ca)\bar{b}$, respectively. Based on the Raman tensors (Rt), the A_g mode appears under $b(aa)\bar{b}$ ($Z(XX)\bar{Z}$) while the B_{2g} mode under $b(ca)\bar{b}$ ($Z(YX)\bar{Z}$). A review on the Raman spectrum of black phosphorus will be presented in section 5.

Based on symmetry analysis and polarization Raman measurements, we can effectively assign the peaks observed in Raman spectra. In many cases, the number of peaks in a Raman spectrum is far smaller than the number of Raman active modes. The appearance of a Raman active mode is still affected by several factors: (1) scattering configuration. Besides the Raman activity of a Raman mode, an appropriate scattering configuration is necessary for its appearance in the Raman spectrum, as mentioned above. For example, the E_{1g} mode of bulk MoS_2 cannot be detected under the back-scattering configuration. (2) Electron–phonon coupling. The intensity of a Raman active mode is proportional to the strength square of electron–phonon coupling in its Raman processes. (3) Excitation energy. One can tune the laser excitation energy to match the electron transition energy of the sample to enhance the Raman intensity of some Raman modes. (4) Instrument throughput. Many components in a Raman system exhibit wavelength-dependent efficiency for the laser excitation and Raman signal, and finally affect its signal throughput. For example, the Raman filter can determine the limitations in probing the ultralow-frequency modes.

3 Raman spectra of different types of bulk LMs

3.1 Semiconductors

Bulk TMDs, such as MoS_2 , WS_2 , WSe_2 and MoSe_2 , have attracted much attention due to their electronic and optical properties.⁸ Recent advances on TMDs are collected in a themed issue on 2D transition metal dichalcogenide nanosheets in *Chemical Society Reviews*.^{10,43–56} In particular, ref. 10 reviewed the Raman scattering of TMDs from monolayer, multilayer to bulk materials. MoS_2 , WS_2 , WSe_2 and MoSe_2 have D_{6h} symmetry. Based on the symmetry analysis (section 2), A_{1g} , E_{1g} and $2E_{2g}$ are expected in the Raman spectra of these TMDs. However, only A_{1g} and $2E_{2g}$ will come up under the back-scattering configuration. The Raman spectra of MoS_2 , WS_2 , WSe_2 and MoSe_2 are presented in Fig. 3. Although they share a similar crystal structure, each of them shows a distinctive Raman spectrum (Fig. 3). A_{1g} and $2E_{2g}$ have been detected and assigned as follows:¹⁰ MoS_2 : E_{2g}^2 ($\sim 32.5 \text{ cm}^{-1}$), E_{2g}^1 ($\sim 383.3 \text{ cm}^{-1}$), A_{1g} ($\sim 408.6 \text{ cm}^{-1}$); WS_2 : E_{2g}^2 ($\sim 27.5 \text{ cm}^{-1}$), E_{2g}^1 ($\sim 356.5 \text{ cm}^{-1}$), A_{1g} ($\sim 420.0 \text{ cm}^{-1}$); WSe_2 : E_{2g}^2 ($\sim 23.8 \text{ cm}^{-1}$), E_{2g}^1 ($\sim 248.0 \text{ cm}^{-1}$), A_{1g} ($\sim 251.0 \text{ cm}^{-1}$) (detected by 633 nm excitation; see Fig. S1 in the ESI†); MoSe_2 :^{57,58} E_{2g}^2 ($\sim 25.5 \text{ cm}^{-1}$), E_{2g}^1 ($\sim 285.0 \text{ cm}^{-1}$), A_{1g} ($\sim 240.6 \text{ cm}^{-1}$). Besides the phonons at the Γ point in the Brillouin zone (BZ), those from the M point also contribute to the observed Raman peaks in these TMDs. The modes $\sim 452.0 \text{ cm}^{-1}$ in MoS_2 , $\sim 351.4 \text{ cm}^{-1}$ in WS_2 and $\sim 351.4 \text{ cm}^{-1}$ in WSe_2 are assigned to the overtone of LA phonons at the M point ($2\text{LA}(M)$) under the resonant excitation conditions.^{10,38,59,60} Actually, more combination modes from phonons at the M point are revealed, for example, $\sim 174 \text{ cm}^{-1}$, $\sim 231 \text{ cm}^{-1}$ and $\sim 297 \text{ cm}^{-1}$ in WS_2 are assigned to $\text{LA}(M)$,



Bulk GaSe is well known as a second-order nonlinear-optical material.⁶¹ The thin film of GaSe has been used for the fabrication of photo-detectors.⁶² Both GaSe (β -GaSe) and GaS (β -GaS) belong to D_{6h} . A single tetralayer is composed of four

CuS belongs to D_{6h} above 55 K, but decreases to D_{2h} below 55 K.⁶⁴ Its unit cell contains 12 atoms; thus 36 normal vibration modes at Γ are expected. Above 55 K, 36 normal vibration modes are expressed as:⁶⁴ $\Gamma = 2A_{1g} + 4A_{2u} + 4B_{2g} + 2B_{1u} + 2E_{1g} + 4E_{1u} + 4E_{2g} + 2E_{2u}$, where $2A_{1g}$, $2E_{1g}$ and $4E_{2g}$ are Raman active. Seven Raman peaks have been observed by Ishii *et al.*, 19 cm⁻¹, 62 cm⁻¹, 65 cm⁻¹, 112 cm⁻¹, 142 cm⁻¹, 267 cm⁻¹, and 457 cm⁻¹.⁶⁴ They only assigned two modes, 19 cm⁻¹ and 457 cm⁻¹, as E_{2g} and A_{1g} , respectively. We observed three modes (~ 19.3 cm⁻¹, ~ 61.8 cm⁻¹ and ~ 266.3 cm⁻¹) under 532 nm excitation and one mode (~ 65.0 cm⁻¹) under 633 nm excitation (see Fig. S1 in the ESI†) under both XX and YX configurations. These four modes correspond to $4E_{2g}$, which are denoted as E_{2g}^4 (~ 19.3 cm⁻¹), E_{2g}^3 (~ 61.8 cm⁻¹), E_{2g}^2 (~ 65.0 cm⁻¹) and E_{2g}^1 (~ 266.3 cm⁻¹). Three modes, ~ 113.0 cm⁻¹, ~ 140.0 cm⁻¹ and ~ 474.3 cm⁻¹, are only observed under the XX configuration. We assign ~ 140.0 cm⁻¹ and ~ 474.3 cm⁻¹ as A_{1g}^2 (~ 140.0 cm⁻¹) and A_{1g}^1 (~ 474.3 cm⁻¹), respectively.⁶⁵ The asymmetric mode ~ 113.0 cm⁻¹ needs further clarification. The E_{2g}^4 mode in CuS_{1-x}Se_x ($0 < x < 1$) had shown the soft mode behavior with decreasing temperature from 300 K to 80 K, which was attributed to the structure phase transition.⁶⁴

The basic structure of SnSe_2 (or SnS_2) is a trilayer in which the Sn layer is sandwiched between two atomic layers of Se (S) atoms. The different stackings of these trilayers will produce possible polytypes including 2H (one trilayer), 4H (two trilayers) and 6H (three trilayers). The 6H polytype further includes two types, 6Ha and 6Hb.²⁴ These polytypes exhibit different symmetries, D_{3d} for both 2H and 6Hb, C_{6v} for 4H and C_{3v} for 6Ha. Based on the present Raman spectrum, SnSe_2 here is actually 6Hb- SnSe_2 .²⁴ Its 27 normal modes are represented by:²⁴ $\Gamma = 4A_{1g} + 5A_{2u} + 4E_g + 5E_{2u}$, where $4A_{1g}$ and $4E_g$ are Raman active. $2A_{1g}$ (35.5 cm^{-1} and 184.5 cm^{-1}) and $2E_g$ (20.5 cm^{-1} and 109.0 cm^{-1}) have been assigned by Smith *et al.*²⁴ In our Raman spectrum, the four modes lie at $\sim 19.7 \text{ cm}^{-1}$ (E_g^2), $\sim 34.4 \text{ cm}^{-1}$ (A_{1g}^2), $\sim 109.0 \text{ cm}^{-1}$ (E_g^1) and $\sim 182.3 \text{ cm}^{-1}$ (A_{1g}^1), respectively. In addition, we observed several weak modes, $\sim 70.9 \text{ cm}^{-1}$, $\sim 147.2 \text{ cm}^{-1}$, $\sim 217.9 \text{ cm}^{-1}$ (detected by 633 nm excitation; see Fig. S2 in the ESI†), $\sim 251.0 \text{ cm}^{-1}$ (detected by 633 nm excitation; see Fig. S2 in the ESI†) and $\sim 340.1 \text{ cm}^{-1}$. Two modes, $\sim 70.9 \text{ cm}^{-1}$ and $\sim 340.1 \text{ cm}^{-1}$, can be assigned to A_{1g} , while the mode at $\sim 147.2 \text{ cm}^{-1}$ can be assigned to E_g . The other two modes, $\sim 217.9 \text{ cm}^{-1}$ and $\sim 251.0 \text{ cm}^{-1}$, are much broader in width, which probably comes from the phonons away from the Γ point.

GeSe , GeS , SnS and SnSe belong to D_{2h} with 8 atoms in a unit cell forming two tetralayers. 24 normal vibration modes of GeSe are expected and denoted as follows: $\Gamma = 4A_g + 4B_{1u} + 2B_{1g} + 2A_u + 4B_{2g} + 4B_{3u} + 2B_{3g} + 2B_{2u}$, where $4A_g$, $2B_{1g}$, $4B_{2g}$ and $2B_{3g}$ are Raman active.³⁴ Its Raman modes have been assigned in section 2:³⁴ A_g^4 ($\sim 40 \text{ cm}^{-1}$), A_g^3 ($\sim 82 \text{ cm}^{-1}$), A_g^2 ($\sim 175 \text{ cm}^{-1}$) and A_g^1 ($\sim 188 \text{ cm}^{-1}$), B_{3g}^2 ($\sim 39 \text{ cm}^{-1}$) and B_{3g}^1 ($\sim 151 \text{ cm}^{-1}$). A_g^3 ($\sim 40 \text{ cm}^{-1}$) and B_{3g}^2 ($\sim 39 \text{ cm}^{-1}$) are identified as the interlayer shear modes within the bc plane.³⁴

GaTe belongs to C_{2h} .⁶⁶ Its 36 normal vibration modes are represented by $\Gamma = 12A_g + 6B_g + 6A_u + 12B_u$, where $12A_g$ and $6B_g$ modes are Raman active, thus 18 Raman modes are expected.⁶⁶ Based on the Raman tensors of A_g and B_g ,²⁹ 10 Raman modes are assigned as follows: A_g ($\sim 40.5 \text{ cm}^{-1}$, $\sim 52.1 \text{ cm}^{-1}$, $\sim 66.2 \text{ cm}^{-1}$, $\sim 109.4 \text{ cm}^{-1}$, $\sim 114.6 \text{ cm}^{-1}$, $\sim 176 \text{ cm}^{-1}$, $\sim 207.7 \text{ cm}^{-1}$ and $\sim 268.5 \text{ cm}^{-1}$) and B_g ($\sim 56.3 \text{ cm}^{-1}$ and $\sim 162.6 \text{ cm}^{-1}$).^{66,67}

ReSe_2 has C_i symmetry,⁶⁸ whose 36 normal vibration modes are represented by $\Gamma = 18A_g + 18A_u$, where $18A_g$ modes are Raman active. Thus, all the vibration modes in its Raman spectrum are denoted by A_g . These modes lie at $\sim 112.1 \text{ cm}^{-1}$, $\sim 118.3 \text{ cm}^{-1}$, $\sim 121.4 \text{ cm}^{-1}$, $\sim 124.5 \text{ cm}^{-1}$, $\sim 159.6 \text{ cm}^{-1}$, $\sim 172.5 \text{ cm}^{-1}$, $\sim 117.1 \text{ cm}^{-1}$, $\sim 180.7 \text{ cm}^{-1}$, $\sim 192.0 \text{ cm}^{-1}$, $\sim 196.1 \text{ cm}^{-1}$, $\sim 209.9 \text{ cm}^{-1}$, $\sim 218.6 \text{ cm}^{-1}$, $\sim 232.5 \text{ cm}^{-1}$, $\sim 240.0 \text{ cm}^{-1}$, $\sim 248.1 \text{ cm}^{-1}$ and $\sim 260.8 \text{ cm}^{-1}$.

3.2 Topological insulators

Bi_2Se_3 and Bi_2Te_3 have D_{3h} symmetry.⁶⁹ Their quintuple layer is in the sequence of $\text{Se1}(\text{Te1})\text{-Bi-Se2}(\text{Te2})\text{-Bi-Se1}(\text{Te1})$. 15 normal vibration modes are represented by $\Gamma = 2E_g + 2A_{1g} + 3E_u + 3A_{1u}$, where $2E_g$ and $2A_{1g}$ modes are Raman active.⁶⁹ Four modes in Bi_2Se_3 and Bi_2Te_3 have been detected and

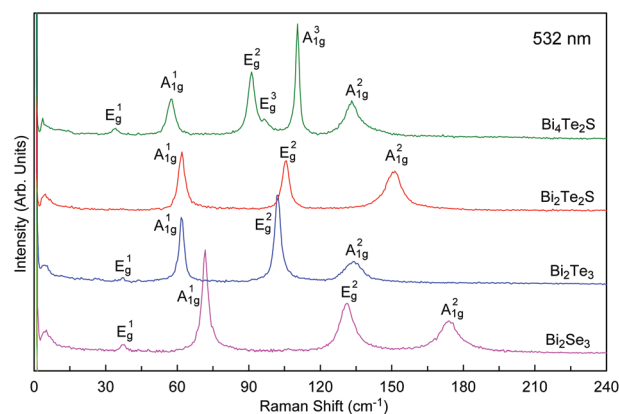


Fig. 4 Raman spectra of Bi_2Se_3 , Bi_2Te_3 , $\text{Bi}_2\text{Te}_2\text{S}$ and $\text{Bi}_4\text{Te}_2\text{S}$.

assigned.^{33,70} These modes are assigned as follows (Fig. 4): Bi_2Se_3 : E_g^1 ($\sim 37.1 \text{ cm}^{-1}$), A_{1g}^1 ($\sim 71.6 \text{ cm}^{-1}$), E_g^2 ($\sim 130.8 \text{ cm}^{-1}$) and A_{1g}^2 ($\sim 173.6 \text{ cm}^{-1}$); Bi_2Te_3 : E_g^1 ($\sim 37.1 \text{ cm}^{-1}$), A_{1g}^1 ($\sim 61.6 \text{ cm}^{-1}$), E_g^2 ($\sim 102.3 \text{ cm}^{-1}$) and A_{1g}^2 ($\sim 133.9 \text{ cm}^{-1}$). When the Te2 atomic layer of the quintuple layer (Te1-Bi-Te2-Bi-Te1) is replaced by a S atomic layer, Bi_2Te_3 will change into $\text{Bi}_2\text{Te}_2\text{S}$ (Te1-Bi-S-Bi-Te1). $\text{Bi}_2\text{Te}_2\text{S}$ also has D_{3h} symmetry. These modes are assigned as E_g^1 ($\sim 34.9 \text{ cm}^{-1}$) (detected by 633 nm excitation; see Fig. S1 in the ESI†), A_{1g}^1 ($\sim 61.6 \text{ cm}^{-1}$), E_g^2 ($\sim 105.4 \text{ cm}^{-1}$) and A_{1g}^2 ($\sim 150.9 \text{ cm}^{-1}$). When an extra Bi bilayer between interlayer Te1-Te1 space is included, $\text{Bi}_2\text{Te}_2\text{S}$ will further change into $\text{Bi}_4\text{Te}_2\text{S}$ ($\text{Bi-Bi-Te1-Bi-S-Bi-Te1}$). There are six modes in the Raman spectrum of $\text{Bi}_4\text{Te}_2\text{S}$: $\sim 33.7 \text{ cm}^{-1}$, $\sim 90.7 \text{ cm}^{-1}$, $\sim 96.4 \text{ cm}^{-1}$ (XX, YX) and $\sim 57.3 \text{ cm}^{-1}$, $\sim 110.4 \text{ cm}^{-1}$, $\sim 133.2 \text{ cm}^{-1}$ (XX). We assign these modes as follows: E_{1g}^1 ($\sim 33.7 \text{ cm}^{-1}$), E_{1g}^2 ($\sim 90.7 \text{ cm}^{-1}$), E_{1g}^3 ($\sim 96.4 \text{ cm}^{-1}$), A_{1g}^1 ($\sim 57.3 \text{ cm}^{-1}$), A_{1g}^3 ($\sim 110.4 \text{ cm}^{-1}$) and A_{1g}^2 ($\sim 133.2 \text{ cm}^{-1}$).

3.3 Superconductors, semi-metals and insulators

NbSe_2 is a superconductor.⁷¹ It belongs to D_{6h} with two trilayers in its unit cell. 18 normal vibrational modes are represented by: $\Gamma = 2A_{2u} + 2B_{2g} + B_{1u} + A_{1g} + 2E_{1u} + 2E_{2g} + E_{2u} + E_{1g}$, where A_{1g} , E_{1g} and $2E_{2g}$ modes are Raman active.⁷² These modes were found at 228 cm^{-1} (A_{1g}), 133.7 cm^{-1} (E_{1g}), 237 cm^{-1} (E_{2g}^1) and 29.1 cm^{-1} (E_{2g}^2).⁷² E_{2g}^2 , A_{1g} and E_{2g}^1 in our experiment are found at $\sim 28.4 \text{ cm}^{-1}$ (E_{2g}^2), $\sim 228.7 \text{ cm}^{-1}$ (A_{1g}) and $\sim 237.5 \text{ cm}^{-1}$ (E_{2g}^1), as shown in Fig. 5. Unexpectedly, E_{2g}^1 ($\sim 237.5 \text{ cm}^{-1}$) is only observed by 532 nm excitation, which needs multi-wavelength excitations for further clarification. In addition, we observed three broad modes, $\sim 95.3 \text{ cm}^{-1}$, $\sim 182.6 \text{ cm}^{-1}$ and $\sim 333.5 \text{ cm}^{-1}$. The broad mode $\sim 182.6 \text{ cm}^{-1}$ is assigned as a soft mode, which involves a second-order scattering process of two phonons.^{72–74} Recently, Xi *et al.* obtained the charge-density-wave (CDW) transition temperature (33.5 K in bulk NbSe_2) by measuring the dependency of this soft mode on the temperature.⁷⁵ The other two broad modes need further clarification.

Graphite belongs to D_{6h} with 12 normal vibrational modes represented by: $\Gamma = 2A_{2u} + 2B_{2g} + 2E_{1u} + 2E_{2g}$, where $2E_{2g}$

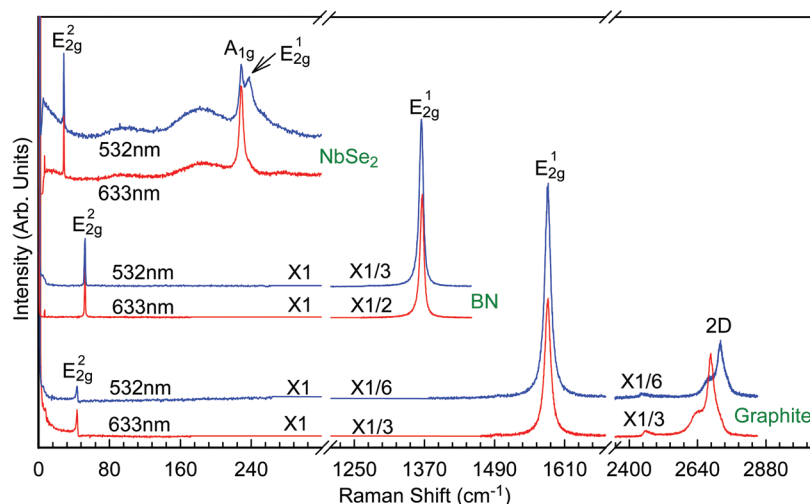


Fig. 5 Raman spectra of NbSe₂, graphite and BN under 633 nm and 532 nm excitations.

Table 1 The frequencies and corresponding assignments of different types of LMs

| Crystal | Symmetry | Assignments of the vibrational modes (cm ⁻¹) |
|------------------------------------|-----------------|---|
| MoS ₂ | D _{6h} | 32.5(E _{2g} ²), 383.3(E _{2g} ¹), 408.6(A _{1g}), 452.0(2LA(M)) |
| MoSe ₂ | D _{6h} | 25.5(E _{2g} ²), 240.6(A _{1g}), 250.5, 285.0(E _{2g} ¹) |
| WS ₂ | D _{6h} | 27.5(E _{2g} ²), 174(LA(M)), 193, 231(A _{1g} (M)), 297(2LA(M)-2E _{2g} ² (M)), 313, 324, 351.4(2LA(M)), 356.5(E _{2g} ¹), 420.0(A _{1g}) |
| WSe ₂ | D _{6h} | 23.8(E _{2g} ²), 138, 248(E _{2g} ¹), 251(A _{1g}), 258(2LA(M)), 307, 359, 372, 394 |
| GaSe | D _{6h} | 19.3(E _{2g} ²), 59.2(E _{1g} ²), 134.0(A _{1g} ²), 209.3(E _{1g} ¹), ^a 212.6(E _{2g} ¹), 307.5(A _{1g} ¹) |
| GaS | D _{6h} | 22.4(E _{2g} ²), 74.8(E _{1g} ²), 188.5(A _{1g} ²), 291.2(E _{1g} ¹), 295.3(E _{2g} ¹), 361.1(A _{1g} ²) |
| CuS | D _{6h} | 19.3(E _{2g} ²), 61.8(E _{2g} ³), 65.0(E _{2g} ²), ^a 113.0, 140.0(A _{1g} ²), 266.3(E _{2g} ¹), 474.3(A _{1g} ¹) |
| 6H-SnSe ₂ | D _{3d} | 19.7(E _{2g} ²), 34.4(A _{1g} ²), 70.9(A _{1g} ³), 109.0(E _{1g} ¹), 147.2(E _{2g} ³), 182.3(A _{1g} ¹), 340.1(A _{1g} ⁴) |
| GeSe | D _{2h} | 39(B _{3g}), 40(A _g ⁴), 82(A _g ³), 151(B _{3g} ¹), 175(A _g ²), ^a 188(A _g ¹) |
| GaTe | C _{2h} | 40.5(A _g), 52.1(A _g), 56.3(B _g), 66.2(A _g), 109.4(A _g), 114.6(A _g), 162.6(B _g), 176.0(A _g), 207.7(A _g), 268.5(A _g) |
| ReSe ₂ ^b | C _i | 112.1, 118.3, 121.4, 124.5, 159.6, 172.5, 177.1, 180.7, 192.0, 196.1, 209.9, 218.6, 232.5, 240.0, 248.1, 260.8, |
| Bi ₂ Se ₃ | D _{3d} | 37.1(E _g ¹), 71.6(A _{1g} ¹), 130.8(E _g ²), 173.6(A _{1g} ²) |
| Bi ₂ Te ₃ | D _{3d} | 37.1(E _g ¹), 61.6(A _{1g} ¹), 102.3(E _g ²), 133.9(A _{1g} ²) |
| Bi ₂ Te ₂ S | D _{3d} | 34.9(E _g ¹), ^a 61.6(A _{1g} ¹), 105.4(E _g ²), 150.9(A _{1g} ²) |
| Bi ₄ Te ₂ S | D _{3d} | 33.7(E _g ¹), 57.3(A _{1g} ¹), 90.7(E _g ²), 96.4(E _g ³), 110.4(A _{1g} ³), 133.2(A _{1g} ²) |
| Graphite | D _{6h} | 43.5(E _{2g} ²), 1581.3(E _{2g} ¹), 2676.5, ^c 2720.8 ^c |
| BN | D _{6h} | 52.2(E _{2g} ²), 1364.7(E _{2g} ¹) |
| NbSe ₂ | D _{6h} | 28.4(E _{2g} ²), 95.3, 182.6, 228.7(A _{1g} ¹), 237.5(E _{2g} ¹), 333.5 |
| MoTe ₂ ^d | D _{6h} | 27.5(E _{2g} ²), 116.8(E _{1g} ¹), 174.0(A _{1g}), 234.0(E _{2g} ¹) |
| WTe ₂ ^{e,f} | C _{2v} | 78.9, 88.4, 109.9, 114.6, 129.9, 160.6, 207.7 |
| BP ^g | D _{2h} | 197(B _{1g}), 233(B _{3g} ¹), 365(A _{1g} ¹), 440(B _{3g} ²), 442(B _{2g}), 470(A _g ²) |
| ReS ₂ ^{b,h} | C _i | 140.3, 145.9, 153.1, 163.6, 217.2, 237.1, 278.3, 284.2, 307.8, 311.0, 320.6, 324.9, 348.8, 368.9, 377.9, 407.3, 418.7, 438.0 |
| 2H-SnS ₂ ⁱ | D _{3d} | 205.5(E _g), 315.0(A _{1g}) |
| 4H-SnS ₂ ⁱ | C _{6v} | 28.5(E), 200.0(E), 214.0(E), 313.5(A ₁) |
| SnS ^j | D _{2h} | 40(A _g), 49(B _{3g}), 70(B _{2g}), 85(B _{2g}), 95(A _g), 164(B _{3g}), 192(A _g), 208(B _{1g}), 218(A _g), 290(B _{2g}) |
| SnSe ^j | D _{2h} | 33(A _g), 37(B _{3g}), 57(B _{1g}), 71(A _g), 108(B _{3g}), 130(A _g), 133(B _{1g}), 151(A _g) |
| ZrS ₂ ^l | D _{3d} | 251(E _g), 316(A _{2u} (LO)), 333(A _{1g}), 350(E _u (LO)), 700(2E _u (LO)) |
| ZrTe ₂ ^k | D _{3d} | 104(E _g), 145(A _{1g}) |
| CoS ₂ ^m | T _h | 289(E _g), 316(T _g), 392(A _g), 416(T _g ²) |
| CoSe ₂ ⁿ | T _h | 188(A _g) |
| HfS ₂ ^o | D _{3d} | 260(E _g), 321(E _u (LO)), 337(A _{1g}) |
| HfSe ₂ ^o | D _{3d} | 96(E _u (TO)), 120(A _{2u} (TO)), 145(E _g), 170(A _{2u} (LO)), 198(A _{1g}), 210(E _u (LO)) |
| HfTe ₂ ^k | D _{3d} | 107(E _g), 149(A _{1g}) |
| TiS ₂ ^p | D _{3d} | 232(E _g), 336(A _{1g}) |
| TiSe ₂ ^q | D _{3d} | 136(E _g), 200(A _{1g}) |
| TiTe ₂ ^k | D _{3d} | 102(E _g), 145(A _{1g}) |
| 1T-TaS ₂ ^r | D _{3d} | 240(E _g), 385(A _{1g}) |
| 1T-TaSe ₂ ^s | D _{3d} | 23(E _{2g} ²), 139(E _{1g}), 207(E _{2g} ¹), 234(A _{1g}) |
| 2H-TaS ₂ ^{k,t} | D _{6h} | 26(E _{2g} ²), 230(E _{1g}), 285(E _{2g} ¹), 400(A _{1g}) |
| 2H-TaSe ₂ ^t | D _{6h} | 23(E _{2g} ²), 139(E _{1g}), 207(E _{2g} ¹), 234(A _{1g}) |
| NbS ₂ ^t | D _{6h} | 31(E _{2g} ²), 260(E _{1g}), 304(E _{2g} ¹), 379(A _{1g}) |
| FeSe ^u | D _{6h} | 106(E _g), 160(A _{1g}), 224(B _{1g}), 234(E _g), 254 |

^a Detected by 633 nm excitation. ^b All the modes belong to A_g. ^c The so-called G' or 2D mode. ^d Ref. 84. ^e Ref. 85. ^f All the modes belong to A. ^g Ref. 42.

^h Ref. 86. ⁱ Ref. 24. ^j Ref. 40. ^k Ref. 87. ^l Ref. 88. ^m Ref. 89. ⁿ Ref. 90. ^o Ref. 91. ^p Ref. 92. ^q Ref. 93. ^r Ref. 94. ^s Ref. 95. ^t Ref. 96. ^u Ref. 97, measured at 3 K.

modes are Raman active.²¹ $2E_{2g}$ modes are found at $\sim 43.5\text{ cm}^{-1}$ (E_{2g}^2) and $\sim 1581.3\text{ cm}^{-1}$ (E_{2g}^1 , usually called G mode). Because of the distinctive band structure of graphite, the phonons from the K point can also participate in the Raman process. For example, the G' mode (or the so-called 2D mode) that comes from the TO phonon close to the K point is found at $\sim 2688\text{ cm}^{-1}$ by 633 nm excitation and at $\sim 2720.8\text{ cm}^{-1}$ by 532 nm excitation.^{76,77} The dependence of the G' peak position on the laser wavelength reflects the high dispersive behavior of the TO branch around the K point.^{78,79} Please refer to the comprehensive review articles for the advances on Raman spectroscopy of graphite and graphene.^{27,80,81}

BN is an insulator which is normally used as a substrate to support high-quality graphene flakes.⁸² It has a similar crystal structure to graphite, in which two carbon atoms in the unit cell are replaced by B and N, respectively. Thus, its lattice vibrations at the Γ point are similar to those of graphite. E_{2g}^2 and E_{2g}^1 in BN lie at $\sim 52.2\text{ cm}^{-1}$ and $\sim 1364.7\text{ cm}^{-1}$.⁸³

The frequencies and corresponding assignments of these Raman modes are summarized in Table 1. Although we re-measured the Raman spectra of various LMs, there are still a large number of LMs waiting for revisits, which require extensive research from the 2D materials community. For the convenience of the subsequent research studies, in Table 1, we summarize the Raman modes of other 25 LMs reported in the literature.

4 Interlayer shear and layer-breathing vibrations

The unit cell of bulk LMs is composed of several rigid layers (RLs) which can be peeled by mechanical exfoliation from bulk materials. For example, there are one RL in ReSe_2 , Bi_2Se_3 and Bi_2Te_3 and two RLs in graphite, TMDs, GaSe(S) , SnSe_2 , BP, GeSe , BN and NbSe_2 . The RLs are single atomic layer (monolayer) for graphite and BN, three atomic layer (trilayer) for TMDs, SnSe_2 and NbSe_2 , four atomic layer (tetralayer) for GaSe(S) , BP and GeSe , and five atomic layer (quintuple layer) for Bi_2Se_3 and Bi_2Te_3 . The stacking of these RLs will form the multilayer structure whose thickness (or layer number) is represented by the number of RLs. The atomic layers in each RL are covalently bonded to one another while the adjacent RLs are coupled *via* weak van der Waals interactions. There exist two types of distinct Raman modes resulting from the relative vibrations between RLs, the shear and layer breathing modes, which are due to relative motions of the planes of RLs, either perpendicular or parallel to their normal. The shear mode is referred to as the C mode in multilayer graphene (MLG) because it was first observed in MLG and provides a direct measurement of the interlayer coupling.²¹ When UFL Raman spectroscopy is extended to various layered materials,^{20,21,30,98–104,115,117,118,130–132} the shear mode had been denoted as the S or LS mode, or LSM. Similarly, the layer breathing mode has been denoted as the B or LB mode, or LBM, and the layer compressing mode in a few literatures. As

for a general notation for interlayer vibration modes in layered materials, we denote the shear mode and the layer breathing mode as the S and LB modes, respectively. No S or LB modes are expected in bulk LMs which have only one RL in its unit cell (for example, ReSe_2 and Bi_2Se_3).

Only the S modes were observed in Bernal-stacked MLGs, where the S modes were found to decrease in frequency with decreasing layer numbers.²¹ The S mode has been used to identify the layer number and probe ultralow-energy electronic excitations in MLGs.²¹ However, no LB modes were detected in Bernal-stacked MLG. Both the interlayer S and LB modes were detected in multilayer TMDs.^{20,30,98} The investigations of S and LB modes now start to expand to LMs with low symmetries, such as BP and ReSe_2 .^{99–102} However, the S and LB modes are only revealed in several LMs, there are various LMs waiting for explorations.

Next, we first review the main results of a linear chain model (LCM), which can predict the frequencies of the S and LB modes of multilayer LMs from that of the bulk ones. Then we apply it to different bulk LMs from which we obtain their shear modulus. Finally, we review the recent studies of the influence of layer stacking configurations on the intensities of S and LB vibrations. The applications of interlayer vibrations to identify the layer number and to probe the interlayer coupling of multilayer LMs can be found in the previous review paper.¹⁰

4.1 Linear chain model for interlayer vibrations

For the S and LB modes, each RL vibrates as a unit and the relative displacements between atoms within RL can be ignored. Therefore, an entire RL can be treated as a single ball once one simulates the S and LB modes in multilayer LMs. Based on this assumption, Zhang *et al.* built a linear chain model (LCM) and successfully produced the frequency trends of both S and LB modes on layer numbers of multilayer MoS_2 .²⁰ LCM has been expanded to general LMs,^{10,103} 2D heterostructures^{13,15,104} and 2D alloys.¹⁹

For in-plane isotropic multilayer LMs, the S mode is doubly degenerate. For an N layer (NL)-LM, there are $N - 1$ pairs of S modes and $N - 1$ LB modes. We denote each S and LB mode of the NL-LM as $S_{N,N-j}$ and $LB_{N,N-j}$, respectively, where N is the layer number, j is the number of phonon branches and $j = N - 1, N - 2, \dots, 2, 1$. If one only considers the nearest-neighbor interlayer interactions in the NL-LM, the corresponding dynamic matrix can be built up.¹³ By solving the dynamic matrix, the frequencies of the $S_{N,N-j}$ and $LB_{N,N-j}$ modes in the NL-LM can be, respectively, expressed by

$$\omega(S_{N,N-j}) = \omega(S_{\text{bulk}})\sin(j\pi/2N) \quad (2)$$

and

$$\omega(LB_{N,N-j}) = \omega(LB_{\text{bulk}})\sin(j\pi/2N), \quad (3)$$

where $\omega(S_{\text{bulk}}) = (1/\pi c)\sqrt{\alpha^{\parallel}/\mu}$ and $\omega(LB_{\text{bulk}}) = (1/\pi c)\sqrt{\alpha^{\perp}/\mu}$, c is the speed of light, α^{\parallel} (α^{\perp}) is the interlayer force constant per unit area between two RLs of the LM within the basal plane (along the c axis), and μ is the total mass per unit area in

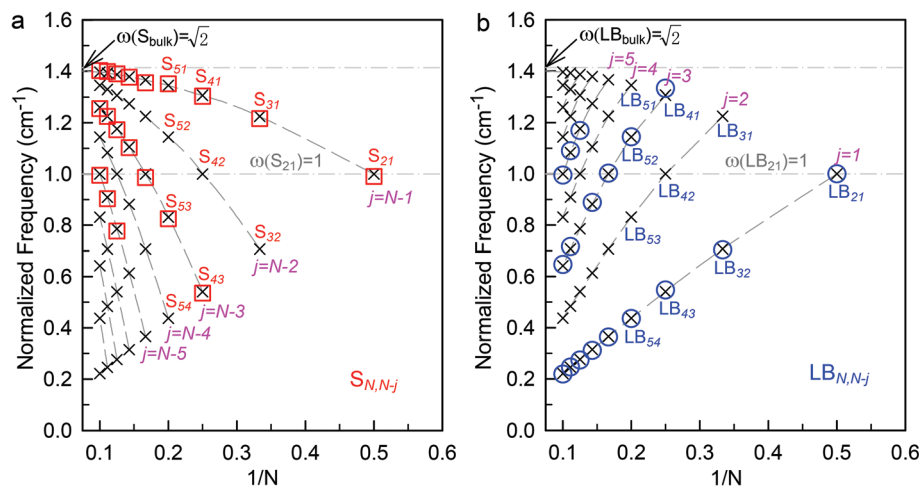


Fig. 6 The frequency of the interlayer S (a) and LB (b) modes in multilayer LMs as a function of inverse layer number (N), where $\omega(S_{21})$ and $\omega(LB_{21})$ are normalized to 1. The squares in (a) and circles in (b) are the normalized experimental frequencies²⁰ of the S and LB modes in multilayer MoS₂ by the corresponding $\omega(S_{21})$ and $\omega(LB_{21})$, respectively.

each RL of the LM. Based on eqn (2) and (3), $S_{N,1}$ ($LB_{N,1}$) is the highest-frequency S (LB) mode while $S_{N,N-1}$ ($LB_{N,N-1}$) is the lowest one for N layer LM. Fig. 6a shows the branches ($j = N - 1, N - 2, \dots$) for the S modes and Fig. 6b shows the branches ($j = 1, 2, \dots$) for the LB modes. In Fig. 6, it is found that once $\omega(S_{\text{bulk}})$ and $\omega(LB_{\text{bulk}})$ are normalized to $\sqrt{2}$, the frequency of the S and LB modes of the bilayer LM is equal to 1, i.e., $\omega(S_{21}) = \omega(LB_{21}) = 1$.

The normalized experimental frequencies²⁰ of the S and LB modes in multilayer MoS₂ by the corresponding $\omega(S_{21})$ and $\omega(LB_{21})$ are included in the squares in Fig. 6(a) and circles in Fig. 6(b), respectively. The experimental data can be well modeled by the LCM, indicating that the interaction between LM flakes and the substrate can be neglected. One can see that the observed S modes in multilayer MoS₂ mainly come from the branches ($j = N - 1, N - 3$ and $N - 5$) whose frequency increases with increasing N , while the observed LB modes mainly come from the branches ($j = 1, 3, 5$) whose frequency decreases with increasing N . However, in Bernal-stacked multilayer graphenes,²¹ only the $j = N - 1$ branch is detected for the S modes. The LCM of eqn (2) and (3) describes a robust link between $\omega(S_{N,N-j})$ ($\omega(LB_{N,N-j})$) and the corresponding frequency in bulk LMs. Once $\omega(S_{\text{bulk}})$ or $\omega(LB_{\text{bulk}})$ is measured for a specific LM, one can obtain the frequency of the S and LB modes in N L-LMs. This affords a fast method to characterize the flake thickness of multilayer LMs, as was done for the flakes of 2D alloy.¹⁹

4.2 Shear modulus

We now apply the LCM to the studied LMs. We mainly focus on the S modes of bulk LMs because they are usually Raman active. From $\omega(S_{\text{bulk}})$, we can obtain α^{\parallel} in bulk LMs. For MoS₂, $\omega(S_{\text{bulk}}) \sim 32.5 \text{ cm}^{-1}$, $\mu = 3.0 \times 10^{-7} \text{ g cm}^{-2}$, and we can obtain $\alpha^{\parallel} = 2.82 \times 10^{19} \text{ N m}^{-3}$. α^{\parallel} times the interlayer distance (d) gives the shear modulus of $\sim 18.9 \text{ GPa}$ for bulk MoS₂.²⁰ For graphite, $\omega(S_{\text{bulk}}) \sim 43.5 \text{ cm}^{-1}$, $\mu = 7.6 \times 10^{-8} \text{ g cm}^{-2}$, we have

$\alpha^{\parallel} = 1.28 \times 10^{19} \text{ N m}^{-3}$ and the shear modulus is $\sim 4.3 \text{ GPa}$.²¹ Thus, one can easily obtain the shear modulus for each bulk LM once its $\omega(S_{\text{bulk}})$ is detected by the ultralow-frequency technique.²¹ The in-plane lattice constant (a), interlayer distance (d), ω_S (bulk), interlayer force constant per unit area (α^{\parallel}), shear modulus of various LMs and their corresponding references are summarized in Table 2. Here a and d are taken from the Inorganic Crystal Structure Database (ICSD). It should be noted that D_{2h} of bulk GeSe breaks the degenerate S modes within the bc plane and gives two S modes for bulk GeSe, i.e., $\sim 40 \text{ cm}^{-1}$ along the c axis and $\sim 39 \text{ cm}^{-1}$ along the b axis. Thus, we have two interlayer force constants and two corresponding shear modulus (Table 2). In the case of 6Hb-SnSe₂, 2 S modes are $E_g + E_u$. The E_g mode is observed at $\sim 19.7 \text{ cm}^{-1}$. Interpretation of the interlayer force constant of 6Hb-SnSe₂ needs more studies on the observation of the E_u mode or the E_g mode in few-layer 6Hb-SnSe₂. The shear modulus obtained here is in good agreement with the reported experimental value for MoS₂ and NbSe₂,¹⁰⁵ for GaS and GaSe,¹⁰⁶ and for graphite.¹⁰⁷ $\omega(S_{\text{bulk}})$ in graphite and BN are relatively higher than in other materials; however, small in-plane lattice constants and interlayer distance result in the smaller interlayer force constant and shear modulus. The shear modulus reflects the deformation of LMs when they are applied by an external strain parallel to the layer plane, which leads to the modification of electrical and phonon structures for LMs.^{108–110}

4.3 Stacking-configuration dependent interlayer mode intensity

Different types of layer stacking configurations are found in LMs. For example, there are two types of layer stackings in multilayer graphene, Bernal (AB) and Rhombohedral (ABC) stackings. In bulk and synthesized multilayer MX₂ TMDs, in addition to the most stable, dominant and natural 2H stacking

Table 2 In-plane lattice constant (a), interlayer distance (d), $\omega(\text{S}_{\text{bulk}})$, interlayer force constant per unit area (α^{ll}), shear modulus (C_{44}) determined by the S mode frequency and that (C_{44}^*) obtained by other methods

| Crystal | a (10^{-8} cm) | d (10^{-8} cm) | ω_{S} (bulk) (cm^{-1}) | α^{ll} (10^{19} N m $^{-3}$) | C_{44} (GPa) | C_{44}^* (GPa) |
|-------------------|------------------------|------------------------|--|---|-------------------|------------------------------|
| MoS ₂ | 3.15 | 6.15 | 32.5 | 2.82 | 18.9 | 18.6 ^a |
| MoSe ₂ | 3.29 | 6.46 | 25.5 | 2.60 | 16.8 | |
| WS ₂ | 3.18 | 6.25 | 27.5 | 3.16 | 19.7 | |
| WSe ₂ | 3.28 | 6.48 | 23.8 | 3.06 | 19.8 | |
| GaSe | 3.75 | 7.96 | 19.3 | 1.44 | 11.5 | 9.0 \pm 1 ^b |
| GaS | 3.59 | 7.75 | 22.4 | 1.38 | 10.6 | 9.96 \pm 0.15 ^b |
| CuS | 3.79 | 8.17 | 19.3 | 1.73 | 14.2 | |
| Graphite | 2.46 | 3.35 | 43.5 | 1.28 | 04.3 | 4.6 ^c |
| BN | 2.50 | 3.33 | 52.2 | 1.83 | 06.1 | |
| NbSe ₂ | 3.44 | 6.27 | 28.4 | 2.92 | 18.3 | 19.0 ^a |
| GeSe | 4.38 ^d | 5.41 | 40.0 ^f | 4.26 | 23.1 | |
| GeSe | 3.83 ^e | 5.41 | 39.0 ^g | 4.05 | 21.9 | |

^a Ref. 105. ^b Ref. 106. ^c Ref. 107. ^d $c = 4.38$. ^e $b = 3.83$. ^f Along the c axis. ^g Along the b axis.

pattern (Fig. 7a), 3R stacking (Fig. 7b) also exists.^{111–113} It should be pointed out that 2H and 3R of MX₂ are actually very similar to AB and ABC stacking of graphene, respectively. Moreover, one can re-stack the synthesized monolayers to create twisted multilayers (characterized by the mutual rotation angle θ) with new properties.^{13,15,114,115} Actually, $\theta = 60^\circ$ corresponds to 2H stacking, while $\theta = 0^\circ$ is 3R stacking. The re-stacking of monolayers obtained from different LMs is considered to be a potential tool to create artificially vdWHs for electronic and optoelectronic applications.

The intensity of the S (LB) mode is found to be strongly dependent on layer stacking configurations. Zhang *et al.* found that the highest-frequency S modes ($S_{N,1}$) which have been detected in multilayer graphenes with AB stacking totally disappear in those with ABC stacking at room temperature.^{21,103} The lowest-frequency S mode ($S_{N,N-1}$) is not observed in AB stacked trilayer graphene,²¹ but detected by Lui *et al.* in ABC stacked by suspending the sample and increasing the laser power up to ~ 9 mW.¹¹⁷ Puretzy *et al.* found that the intensity of S modes ($S_{N,1}$) in bilayer MoSe₂ with 3R stacking drops by a factor of 3.9 compared to 2H stacking, which is accompanied by a redshift of 0.4 cm^{-1} (Fig. 7c).¹¹¹ Similar drops in intensity are further revealed in multilayer structures.^{111,113} The significant differences in intensity serve as fingerprints to characterize layer stacking configurations. Recently, Luo *et al.* proposed a general bond polarizability model to calculate the intensity of S modes in LMs with different stacking configurations.¹¹⁸ They found that the change in polarizability is maximized for the lowest-frequency S mode ($S_{N,N-1}$) in ABC stacked materials, but not for the highest-frequency S mode ($S_{N,1}$) in AB stacked materials, regardless of the details of the space group.¹¹⁸ Here, we can see that interlayer vibrations can be used to characterize not only the layer numbers, but also layer stacking configurations.

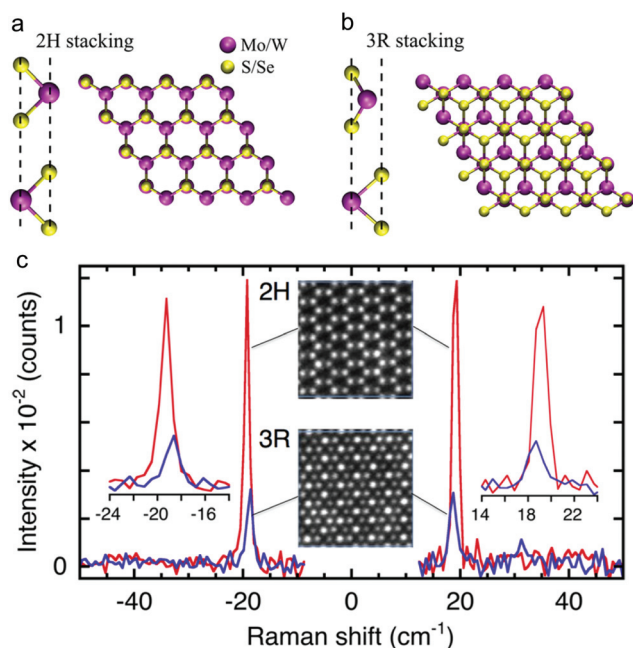


Fig. 7 Side and top views of (a) 2H and (b) 3R stacking patterns of bilayer MX₂. (c) Raman spectra of bilayer MoSe₂ for 2H and 3R stacking patterns. Stokes (right) and anti-Stokes (left) low-frequency Raman spectra of MoSe₂ bilayers suspended on a TEM grid. The insets show atomic resolution STEM images of the 2H (top) and 3R (bottom) stacking patterns. Reproduced with permission from ref. 111. Copyright 2015, American Chemical Society.

5 In-plane anisotropic LMs

Many LMs with a high symmetry (D_{6h}), such as graphite and TMDs, have been under intensive investigation.^{8,10,26,27,81} The properties of these LMs are isotropic with the ab plane because of D_{6h} symmetry. Other LMs that have lower symmetry, such as BP (D_{2h}) and ReSe₂ (C_i), have now started receiving extensive attention.^{100,111,119} BP is a narrow gap (0.3 eV in bulk) semiconductor which bridges the space between zero-gap graphene and large-gap TMDs. Thin film BP has a very high Hall mobility, $\sim 1000 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$, which is predicted to be up to $\sim 10\,000 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$ in a monolayer.^{120,121} As manifested by its optical conductivity and Hall mobility, BP has a

very strong in-plane anisotropy.¹¹⁹ This in-plane anisotropy actually comes from the nature of D_{2h} . Thus, GeSe(S) and SnSe(S) should have similar in-plane anisotropies. The nature of anisotropy within the layer plane has potential for polarizers, polarization sensors, plasmonic devices and high-performance transistors.^{119,122,123}

The in-plane anisotropic properties in ReSe₂ can be revealed by optical transmission and reflection normal to the layer plane and by Raman scattering.^{86,100,124–127} Recent advances on these low-symmetry LMs prove that Raman spectroscopy has potential in revealing the in-plane anisotropy, especially on polarization-resolved and ultralow-frequency Raman spectroscopy. For example, in an anisotropic LM, the S modes are non-degenerate and each pair of S modes should be denoted as S^x and S^y . The LCM can also be applied to the non-degenerate S modes, and the frequencies of the $S_{N,N-j}^x$ and $S_{N,N-j}^y$ modes can also be expressed by eqn (2).

Here, we focus on the review of Raman spectroscopy to characterize the in-plane anisotropy in BP and ReSe₂. The polarization-resolved Raman spectra of a BP thin film at the high frequency region have been obtained.^{116,119,128,129} Wang *et al.* found that the peak positions of three modes (A_g^1 , B_{2g} and A_g^2) do not change as the excitation light polarization varies (Fig. 8). However, the relative intensities of these three modes change significantly with incident light polarization, which can be used to identify the crystalline orientation of BP thin films. According to the inelastic neutron scattering measurements on bulk BP, there are two S modes around 19 cm⁻¹ and 52 cm⁻¹, and one LB mode around 87 cm⁻¹. LB

modes in multilayer BP were recently revealed.^{99,130} Ling *et al.* detected three low-frequency modes (~ 26.2 cm⁻¹, ~ 75.6 cm⁻¹ and ~ 85.6 cm⁻¹) in thin BP films. They pointed out that these three modes are the LB modes, and assign them as A_g based on the polarization dependence measurements and theoretical analysis.⁹⁹ The dependencies of LB modes on accurate layer numbers are not revealed because of the difficulty in obtaining few-layer BP. Moreover, experimental studies on revealing the S modes in multilayer BP are still lacking.

The polarization-resolved Raman spectra of monolayer, few-layer and bulk ReSe₂ are discussed by Wolverson *et al.*¹²⁴ No changes in the frequencies of the Raman bands with layer thickness down to one monolayer are observed, but significant changes in the relative intensity of the bands allow the determination of the crystal orientation and the monolayer region. As discussed above, there is only one RL in bulk ReSe₂, which cannot support the interlayer vibration. However, interlayer vibrations in multilayer ReSe₂ and ReS₂ were recently revealed by several groups.^{100–102,131,132} The emergence of S and LB modes in the multilayer structure indicates the non-negligible interlayer coupling and well-defined stacking orders in the ReSe₂ and ReS₂ crystals. In particular, the in-plane anisotropy lifts the degeneracy between S modes vibrating parallel (S^x) and perpendicular (S^y) to the rhenium chains (b axis).^{102,131} Zhao *et al.* predicted and measured two S modes (12.1 cm⁻¹ and 13.2 cm⁻¹) and one LB mode (24.8 cm⁻¹) in bilayer ReSe₂ (Fig. 9a and b) with a strong angular dependence of the

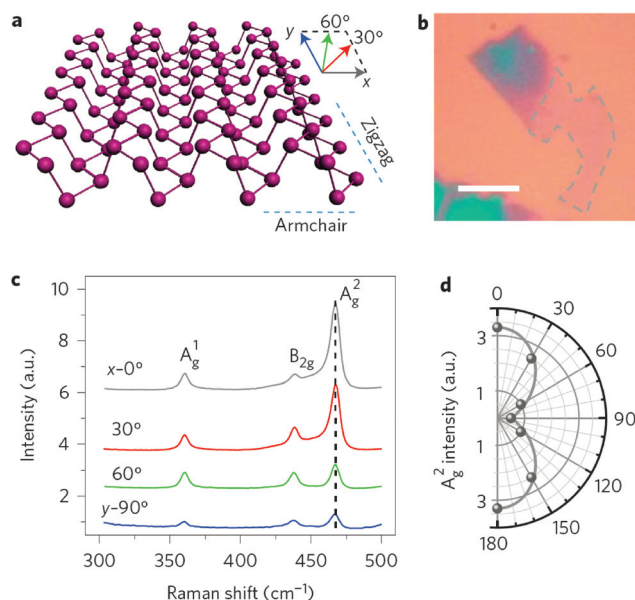


Fig. 8 (a) Schematic of monolayer BP. (b) Optical micrograph of an exfoliated monolayer BP flake on a 285 nm SiO₂/Si substrate. (c) Polarization-resolved Raman spectra of monolayer BP with linearly polarized laser excitation. (d) Intensity of the A_g^2 mode as a function of the excitation laser polarization angle in the xy plane. Reproduced with permission from ref. 116. Copyright 2015, Nature Publishing Group.

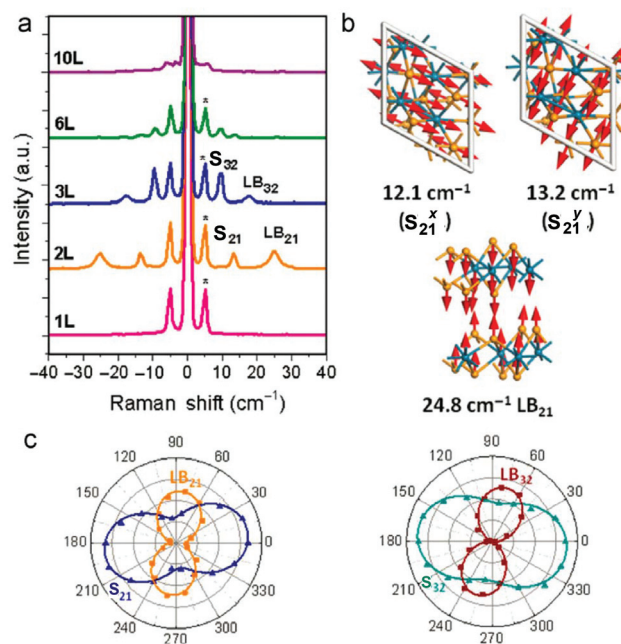


Fig. 9 (a) Raman spectra of few-layer ReSe₂. (b) Schematic of the 3 low frequency vibration modes of bilayer ReSe₂ obtained from first-principles calculations. (c) Polarization-resolved Raman peak intensity of bilayer (left panel) and trilayer (right panel) ReSe₂. The dots in both figures represent experimental data, while the lines are theoretical fits from the Raman tensor analysis. Reproduced with permission from ref. 100. Copyright 2015, Royal Society of Chemistry.

Raman intensity.¹⁰⁰ The frequency between two S modes is only $\sim 1\text{ cm}^{-1}$. However, a larger frequency difference, $\sim 3.5\text{ cm}^{-1}$, between two S modes (13 cm^{-1} and 16.5 cm^{-1}) is revealed in bilayer ReS_2 .^{102,131} Qiao *et al.* revealed two stable stacking orders for N layer ReS_2 .¹³¹ They also revealed the unexpected strong interlayer coupling in these two types of ReS_2 whose force constants are 55–99% compared to those of multilayer MoS_2 . The predicted trends of S and LB modes by LCM are observed, which allows fast layer thickness characterization.^{101,102,131,132} The splitting of the in-plane S modes and the strong angular dependence of the Raman intensity of the S and LB modes are direct fingerprints of the pronounced optical anisotropy in in-plane anisotropic LMs.

6 Conclusion

Lattice vibrations and Raman spectra of bulk LMs are the basic backgrounds to explore the layer-dependent phonon properties of multilayer LMs. Here, we first introduce a unified method based on symmetry analysis and polarization Raman measurements to assign the observed modes in Raman spectra of bulk LMs. Then, we revisit and update the peak positions and mode assignments of different types of bulk LMs in three subsections by re-measuring their Raman spectra. We apply the recent advances on interlayer vibrations of multilayer graphene and TMDs to these LMs from which we obtain their shear modulus. The detected S or LB modes in bulk LMs allow us to build a robust link between the frequencies of the corresponding modes in multilayer LMs and their layer numbers, which will benefit the future layer thickness characterization of multilayer LMs. We also summarize the recent studies of the influence of layer stacking configurations on the intensities of interlayer vibrations. Finally, we review the application of Raman spectroscopy in revealing the in-plane anisotropy by both high-frequency and ultralow-frequency vibrations. We believe that this review will accelerate and benefit the research studies on these different types of LMs, particularly when they are reduced or isolated down to monolayers and a few layers.

Acknowledgements

We acknowledge the support from the National Natural Science Foundation of China (grants 11225421, 11434010 and 11474277).

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